

The University of St. Michael's College and The Pontifical Institute of Mediaeval Studies

THE ALWAY SYMPOSIUM 2023



Sacred Book and Sacred Page in Jewish, Christian, and Muslim Traditions

Sunday, March 19 • Monday, March 20

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Sunday, March 19

OPENING PLENARY

6:30-8:00 pm

“Threading, Folding, Binding across Traditions:
Towards a Genealogy of Manuscript Materiality”

Kristine Rose-Beers

Head of Conservation,
Chester Beatty Library,
Dublin

8:00-9:00 pm

Reception

LOCATION

For the Symposium (Plenaries and Keynote)

Fr. Madden Hall, Carr Hall

100 St. Joseph Street
University of St. Michael's College

Monday, March 20

SYMPOSIUM PLENARIES

8:15 am

Registration & Light Refreshments

8:45-10:15 am

“Transmediality and Visual Culture in
Thirteenth-Century Mosul: Painted Manuscripts
and their Multiple Manifestations”

Ruba Kana'an

Assistant Professor and
Associate Chair of Visual Studies
University of Toronto, Mississauga

10:30 am-12:00 pm

“Sacred Page, Sacred Monument:
Learning from the Taj Mahal
for our Multireligious Societies”

Michael Calabria, OFM

Director, Center for Arab and Medieval Studies
Saint Bonaventure University, Olean, New York

12:00-1:00 pm

Lunch is provided

KEYNOTE ADDRESS

1:00-3:00 pm

“A Culture of Refinement: Jewish
and Muslim Calligraphy in Dialogue”

Judith Olszowy-Schlanger

Director of the Centre for Hebrew
and Jewish Studies, University of Oxford;
President of the Oxford Centre
for Hebrew and Jewish Studies;
Fellow of Corpus Christi College, Oxford

Co-sponsored by the
Anne Tanenbaum Centre for Jewish Studies

SPECIAL EXHIBITION

3:30-5:00 pm

Open House and Display
of Selected Manuscripts

📍 **Thomas Fisher Rare Book Library**

120 St. George Street, 2nd Floor
University of Toronto



RSVP

<https://stmikes.utoronto.ca/event/the-alway-symposium-2023>

For more information: usmc.principalsoffice@utoronto.ca



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